

Docket No.: 064484-0013

PATENT

Reply Under 37 CFR 1.116 - Expedited Procedure - Technology Center 2600

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Iwata IKEDA, et al.

Application No.: 10/668,282

Customer No.: 20277

Filed: September 24, 2003

Confirmation No.: 3504

Group Art Unit: 2625

Examiner: Benjamin O. Dulaney

Title: APPARATUS AND METHOD FOR CREATING A WORKFLOW FOR PRINTING
AND PREPRESSING MANUFACTURING

RESPONSE UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 14, 2011, having a three-month shortened statutory period for reply set to expire on July 14, 2011, reconsideration of the above-identified application is respectfully requested in view of the following remarks.

Remarks begin on page 2 of this paper.